

Substrate effect on supramolecular self-assembly: from semiconductors to metals

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Terephthalic acid (TPA) deposited on Si(111)- 7×7 , Si(111)- $\sqrt{3} \times \sqrt{3}$ -Ag and Ag(111) has been studied as a model system to understand how much passivated semiconductor surfaces differ from semiconductor and metal surfaces in respect of supramolecular self assembly. By scanning tunneling microscopy it is found that TPA molecules do not form any ordered supramolecular structure on the pristine semiconductor surface, due to a strong molecule–substrate interaction. On the contrary, TPA has a weaker interaction with Si(111)- $\sqrt{3} \times \sqrt{3}$ -Ag, leading to the formation of an ordered supramolecular layer stabilized by carboxyl hydrogen bonds. These structures are very similar to the supramolecular layer of TPA formed on Ag(111), indicating that the two substrates behave similarly for what concerns the adsorption of functional organic molecules. However, the deposition of Fe on the TPA layers on Si(111)- $\sqrt{3} \times \sqrt{3}$ -Ag does not induce the formation of two-dimensional metal–organic frameworks which, on the contrary, readily develop on Ag(111). Possible origins of this difference are discussed.

1. Introduction

Functionalization of semiconductor surfaces with organic molecules has attracted much interest recently.^{1–3} It can be used to develop organic–semiconductor hybrid systems, such as molecular electronic devices,^{4,5} optical devices² and chemical sensors.^{2,6,7} However, unlike metal substrates, semiconductor surfaces have a high density of dangling bonds which represent energetically favorable binding sites for organic molecules. This can result in irreversible chemisorption, or even dissociative adsorption, and in a reduced surface diffusivity.³ On the contrary, high surface mobility is a necessary condition for the formation of ordered supramolecular structures. Surface dangling bonds also impose stringent lattice-matching conditions on the growth of the organic layer, leading to poor crystallinity. One promising possibility to overcome these limitations is to deactivate the dangling bonds through passivation with other atoms such as hydrogen, chalcogens or noble metals.⁸

The main aim of the present study is to assess the effect of passivation of semiconductor surfaces by noble metal atoms on supramolecular self-assembly, compared to semiconductor and metal surfaces. To this end, we investigated and compared the deposition of benzene-1,4-dicarboxylic acid ($C_6H_4(COOH)_2$, terephthalic acid, TPA) on the pristine

Si(111)- 7×7 ,⁹ passivated Si(111)- $\sqrt{3} \times \sqrt{3}$ -Ag¹⁰ and clean Ag(111) surfaces.

TPA is considered as a prototypical functional molecule. It has a simple planar structure formed by an aromatic ring and two carboxylic moieties (Fig. 1). It can mediate π – π intermolecular stacking, hydrogen bonding (denoted as H-bonding hereafter) and metal–organic coordination. TPA is one of the most frequently used molecular linkers for the fabrication of three-dimensional (3D) metal–organic frameworks (MOFs) in solution coordination chemistry.^{11,12} The deposition of TPA on solid substrates has also been intensively investigated, particularly in the case of metals, including Au(111),¹³ Pd(111),¹⁴ and Cu(001).¹⁵ For all these cases it has been reported that TPA, or its deprotonated terephthalate form, adsorbs with the phenyl ring parallel to the surface and arranges into a supramolecular layer stabilized by H-bonds. Furthermore, two-dimensional (2D) MOFs could be formed by co-adsorption of *d*-transition metal atoms such as Fe, Co and Cu.^{16–23} Due to its double-ended functionality, when TPA is absorbed in an upright geometry, it can be used for the organic passivation of inorganic surfaces such as Cu(110)²⁴ and TiO₂.²⁵ A perpendicular binding geometry has also been reported for the adsorption of a similar molecule, 2-(trifluoromethyl)-terephthalic acid ($C_6H_3CF_3(COOH)_2$), from solution onto fluorine-terminated Si(111).²⁶ To the best

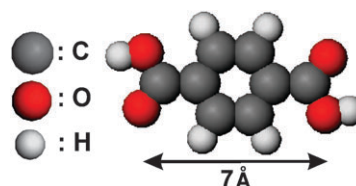


Fig. 1 Molecular structure of terephthalic acid (TPA).

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of our knowledge, however, there has not been any report so far about the deposition of TPA on pristine or passivated semiconductor surfaces.

The Si(111)- $\sqrt{3} \times \sqrt{3}$ -Ag surface is obtained by depositing one monolayer (ML) of silver on the Si(111)- 7×7 substrate and represents a model passivated semiconductor surface for the growth of thin organic films. The adsorbed Ag atoms bind covalently to the Si atoms, leaving no dangling bonds on the surface and thus substantially diminishing its reactivity. Several groups have studied the adsorption of different types of molecules on Si(111)- $\sqrt{3} \times \sqrt{3}$ -Ag, including pentacene,^{27,28} C₆₀,^{29–31} phthalocyanines,³² 3,4,9,10-perylene tetracarboxylic dianhydride (PTCDA),^{33,34} perylene tetracarboxylic di-imide (PTCDI),³⁴ adenine,³⁵ and trimesic acid (TMA).³⁶ All of the organic molecules above were reported to adsorb intact, in a flat geometry, and to form extended ordered layers on the substrate. Furthermore, even supra-molecular open honeycomb networks could be obtained by co-adsorption of melamine with PTCDI³⁷ or cyanuric acid (CA).³⁸

Our measurements confirm that while the molecule–substrate interactions are too strong on Si(111)- 7×7 to allow formation of an ordered TPA monolayer, they become weaker and reversible enough on the passivated Si(111)- $\sqrt{3} \times \sqrt{3}$ -Ag, so as to enable the growth of extended H-bonded supra-molecular structures with many similarities to those on Ag(111). However, 2D MOFs do not form on Si(111)- $\sqrt{3} \times \sqrt{3}$ -Ag when Fe atoms are co-deposited with TPA, while they readily develop on Ag(111).

2. Experimental

The experiments on the Si(111) substrates were carried out in a home-built, room-temperature scanning tunneling microscope (STM). The base pressures of the STM and the preparation chambers are $<1 \times 10^{-10}$ mbar and 5×10^{-10} mbar, respectively. The Si samples ($0.25 \sim 0.3 \times 1 \times 9$ mm) were cut from n-type phosphorus-doped Si(111) wafers ($0.007 \sim 0.013 \Omega$ cm, Siltronix). The Si samples were ultrasonically cleaned in pure ethanol, acetone and deionized water, and then introduced immediately into the UHV chamber. After being outgassed at 500 °C for several hours, the crystals were flashed to 1200 °C in order to obtain a clean 7×7 reconstruction which was always checked before every experiment by STM. For obtaining the Si(111)- $\sqrt{3} \times \sqrt{3}$ -Ag substrates, about 1 ML of silver was deposited from a molybdenum crucible heated by electron bombardment onto the Si substrate held at 450 °C. The TPA molecules ($\geq 99\%$, powder, Fluka) were deposited onto the substrates held at room temperature from a heated glass crucible that was degassed before use. STM tips were electrochemically etched from tungsten wires. All STM measurements on the Si substrates were carried out at room temperature.

The experiments on the single crystal Ag(111) substrate (MaTeck) were carried out in a separate UHV system. The Ag surface was prepared *in situ* by cycles of sputtering with Ar⁺ ions and annealing to 580 °C. The TPA molecules were deposited at room temperature. Then, the Ag sample was

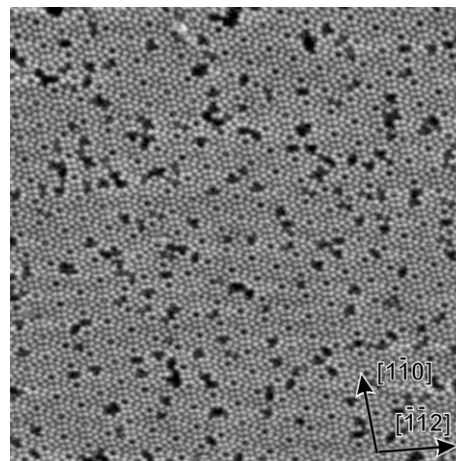


Fig. 2 Overview STM image after TPA deposition on the Si(111)- 7×7 surface. The image size is 50×50 nm. Sample bias (V_s) = +1.9 V, tunneling current (I) = 0.35 nA.

transferred to a second, home-built, low-temperature STM for imaging at approximately 5 K.

3. Results and discussion

3.1 TPA on Si(111)- 7×7

Fig. 2 shows an overview STM image of the Si(111)- 7×7 surface exposed to a sub-ML dose of TPA. While there are only very few defects on the surface before the TPA deposition, many dark spots appear afterwards, which can therefore be assigned to the adsorbed TPA molecules. It is evident that TPA adsorbs randomly on the Si substrate and does not form any ordered supra-molecular structure. A similar behavior has been observed for the deposition of many other organic molecules on Si substrates.^{1,3} This is an indication of a very strong interaction between the molecules and the Si(111)- 7×7 surface which is characterized by a high density of Si dangling bonds (12 on the Si adatoms, 6 on the rest atoms and 18 on the dimers for each 7×7 unit cell). Adsorption of TPA on these sites happens most probably through the formation of irreversible covalent bonds, preventing the surface diffusion needed to form ordered molecular layers.

We have analyzed the different adsorption configurations that TPA adopts on the Si(111)- 7×7 substrate, according to the STM images. This results in the classification of at least 10 different configurations appearing with different frequencies. Fig. 3(a)–(f) show STM images corresponding to the six most common ones. The unit cell of the 7×7 reconstruction is delimited by dotted lines in Fig. 3(a), and is schematically represented in Fig. 3(g), as a reference. For the empty-state tunneling conditions ($V_s = +1.8$ V, $I = 0.2$ nA,) each of the 12 bright protrusions observed in a 7×7 unit cell is the dangling bond of a Si adatom. The unfaulted (U) and faulted (F) half units of the 7×7 reconstruction are explicitly indicated in Fig. 3(a).

In Fig. 3(a) and (b), the dark spot associated with an adsorbed TPA molecule appears in the middle and at the bottom of the unit cell, respectively. In both cases it extends over the dangling bonds of a pair of Si adatoms aligned along

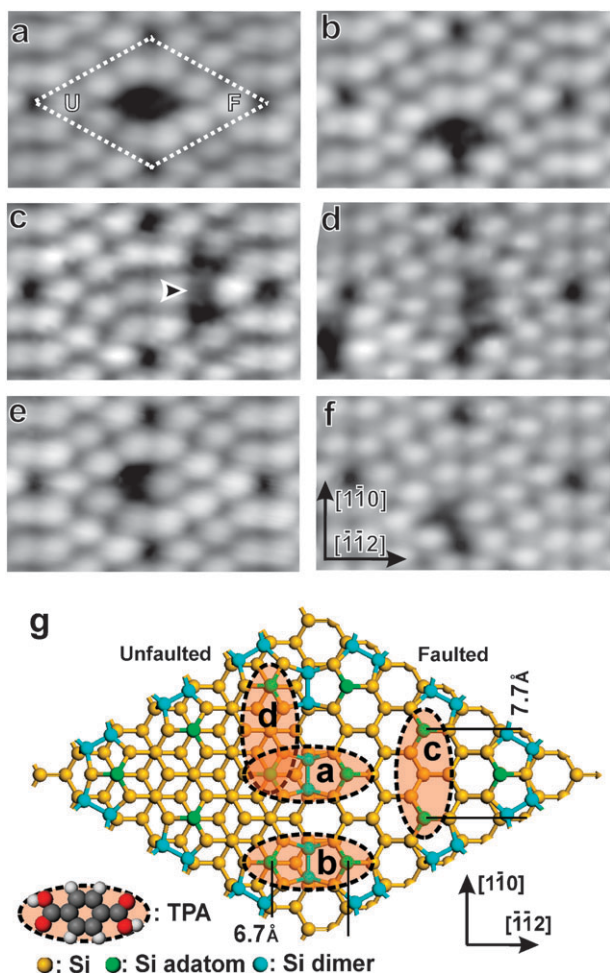


Fig. 3 (a)–(f) Detailed STM images of TPA adsorbed on the Si(111)- 7×7 surface ($V_s = +1.8$ V, $I = 0.2$ nA). The unfaulted and the faulted half units are indicated by U and F, respectively. (g) Schematic drawing of possible TPA adsorption configurations.

$[\bar{1}\bar{1}2]$ (ellipses a and b in Fig. 3(g)). The distance between each pair of Si adatoms is 6.7 Å, which is comparable to the length of the TPA molecule (about 7 Å). Therefore, we propose that, in these configurations, the molecule is predominantly bonded to the Si adatom dangling bonds and that the main axis of the TPA molecule lies parallel to the surface plane. About 20 and 40% of the adsorbed TPA molecules can be found in the configurations of Fig. 3(a) and (b), respectively.

In Fig. 3(c) and (d), the dark spot revealing the presence of a TPA molecule expands over the dangling bonds of two different pairs of $[\bar{1}10]$ -aligned Si adatoms (ellipses c and d in Fig. 3(g), respectively). Also for these cases, the distance between such a pair of adatoms (7.7 Å) is close to the TPA length, suggesting that the molecule might be bonded in a geometry similar to that of Fig. 3(a) and (b). The brighter central part indicated by the arrow head in Fig. 3(c) could be due to a slightly stretched adsorption structure. About 25% of the TPA molecules can be found in the configuration corresponding to Fig. 3(c) and only a few % in that of Fig. 3(d). Most of the remaining TPA molecules adsorb in the configurations shown in Fig. 3(e) (about 10 %) and Fig. 3(f) (a few % of the total). The fact that only a single Si adatom is

covered in those cases might imply a non-planar adsorption geometry.

Although the faulted and the unfaulted halves of the 7×7 unit cell are not identical, adsorption configurations which mirror those shown in Fig. 3(c)–3(f) (where the dark spot is located on the other half of the unit cell) are observed with comparable frequencies. This indicates that TPA molecules do not distinguish between the faulted and unfaulted regions, further strengthening the hypothesis that they bind to the Si adatom dangling bonds. A precise determination of the type and geometry of this binding is beyond the scope of this paper. Nevertheless, reports in the literature indicate that organic molecules containing carboxyl moieties, such as formic acid,^{39,40} methacrylic acid⁴¹ and glycine⁴² adsorb on Si(111)- 7×7 in a deprotonated form through the formation of monodentate Si–O bonds with Si adatoms. On the other hand, benzene has been shown to adsorb by establishing two Si–C bonds with an adatom and a rest atom instead of with a pair of adatoms, because of its reduced size.^{3,43,44} As a consequence, we might speculate that TPA molecules adsorbed in the configurations of Fig. 3(a)–(d) might form two monodentate Si–O bonds with Si adatoms in the positions indicated by the corresponding ellipses in Fig. 3(g). In configurations of Fig. 3(e) and (f), however, TPA could be bonded either through one of its carboxylate moieties, forming a monodentate Si–O bond with a Si adatom, or through its aromatic ring, forming two Si–C bonds, similar to benzene.

Although a more precise assignment needs further spectroscopic investigations (vibrational or electronic), our results clearly indicate that TPA strongly adsorbs on Si(111)- 7×7 in many nonequivalent bonding geometries, which is not compatible with the formation of highly ordered supramolecular structures.

3.2 TPA on Si(111)- $\sqrt{3} \times \sqrt{3}$ -Ag

Fig. 4(a) shows a representative STM image after the sub-ML deposition of TPA on Si(111)- $\sqrt{3} \times \sqrt{3}$ -Ag. The uncovered Si(111)- $\sqrt{3} \times \sqrt{3}$ -Ag surface appears in the left hand side of the image, while the TPA molecular layer is visible on the right. It is clear that, at variance with the deposition on pristine Si(111)- 7×7 , the TPA molecules form a well-ordered layer, most probably due to a weaker molecule–substrate interaction. This is also indicated by the temperature of TPA desorption which sets in at $100 \sim 200$ °C. The TPA layer shows a modulation with a periodicity of about 2 nm along the $[\bar{1}\bar{1}2]$ direction, as indicated by the lines in the upper right part of Fig. 4(a). A similar modulation has also been reported for the adsorption of TMA on the same surface.³⁶

In the detailed STM topography of Fig. 4(b) individual TPA molecules are imaged as brighter protrusions aligned along both the $[\bar{1}\bar{1}2]$ and the $[\bar{1}10]$ directions (several of them are explicitly indicated by circles). Their precise appearance varies substantially from image to image and is dependent on the bias voltage of the tunneling junction and on the tip condition. However, their position and periodicity remain unchanged, as we directly verified by acquiring images in the same sample location at different bias voltages. Fig. 4(b) shows that the modulation of the TPA layer corresponds to an alternation of

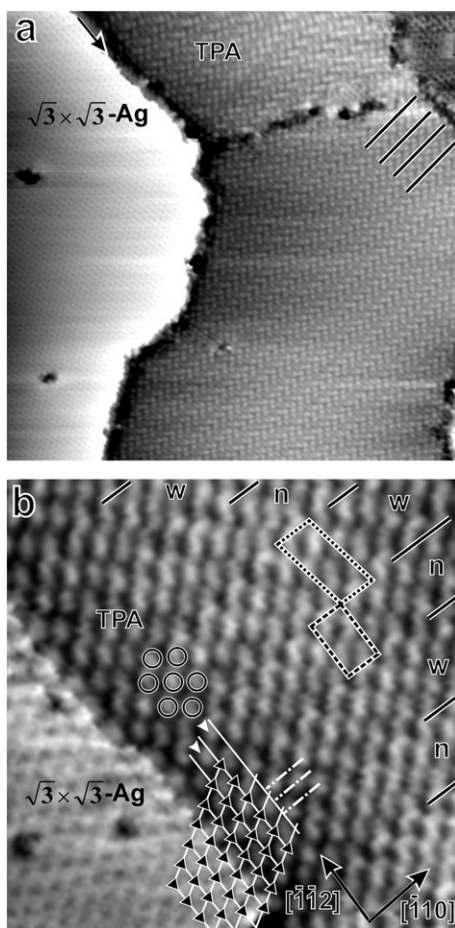


Fig. 4 (a) Overview STM image after the deposition of TPA on the Si(111)- $\sqrt{3} \times \sqrt{3}$ -Ag surface ($V_s = -1.0$ V, $I = 0.2$ nA). A single substrate step (height 3 Å) is indicated by an arrow between the bare Si(111)- $\sqrt{3} \times \sqrt{3}$ -Ag surface area and the TPA layer area. The image size is 50 × 50 nm. (b) Enlarged STM image of the TPA molecular layer ($V_s = -1.8$ V, $I = 0.2$ nA). There is no step between the substrate and the molecular layer. The former appears higher than the latter because of electronic or tip-induced effects. The image size is 14 × 14 nm.

narrower, n, and wider, w, molecular stripes oriented along the $[\bar{1}10]$ direction. The unit cells of the n and the w stripes are different from each other, as indicated by the dashed rectangle and the dotted parallelogram drawn in Fig. 4(b), respectively. In the specific case of Fig. 4(b), the n and the w stripes appear alternately in a nwnw sequence but other irregular sequences such as nww or nnw are also frequently observed.

STM images such as Fig. 4(b), where the TPA layer is imaged at high resolution together with the Si(111)- $\sqrt{3} \times \sqrt{3}$ -Ag substrate, can be used to precisely determine the periodicity of the molecular superstructure. The lattice of the $\sqrt{3} \times \sqrt{3}$ reconstruction is explicitly shown in the lower part of Fig. 4(b), with black triangles indicating the positions of the Si trimers in the honeycomb-chained-triangle structure (these are typically imaged as darker depressions in filled state STM images).⁴⁵ Along $[\bar{1}\bar{1}2]$ the molecules appear to be located in between the Si trimer rows, (white arrow heads in 4(b)), implying that the molecular layer is commensurate with the substrate along $[\bar{1}10]$. This also indicates that the aromatic

part of the TPA molecule preferentially avoids the Si trimers and absorbs close to the Ag atoms where the highest density of occupied states is concentrated. On the contrary, the intermolecular distance along $[\bar{1}\bar{1}2]$ is smaller than the unit length of the Si(111)- $\sqrt{3} \times \sqrt{3}$ -Ag substrate, as shown by the dash-dotted lines in Fig. 4(b).

Fig. 5 shows a possible structural model for the TPA supramolecular layer which is consistent with the experimental observations. TPA molecules adsorb with their plane parallel to the substrate, their phenyl rings close to the Ag atoms and their main axis along the $[\bar{1}10]$ direction.⁴⁶ They form $[\bar{1}10]$ -oriented molecular rows which are held together by stronger O–H···O dimeric H-bonds (intra-row) and weaker C–H···O H-bonds (inter-row), resulting in a brick wall-like molecular arrangement. The length of the dimeric H-bond is equal to 3.5 Å for both the n and w stripes, which is comparable to that observed on metal substrates. The inter-row distance between $[\bar{1}10]$ -oriented molecular rows is longer in the n regions (5.0 Å) than in the w regions (4.7 Å), which is in good agreement with the average value of ~ 5 Å determined from the STM images. The corresponding unit cells can be expressed in matrix notation as

$$\begin{pmatrix} 3 & 0 \\ -3 & 6 \end{pmatrix}$$

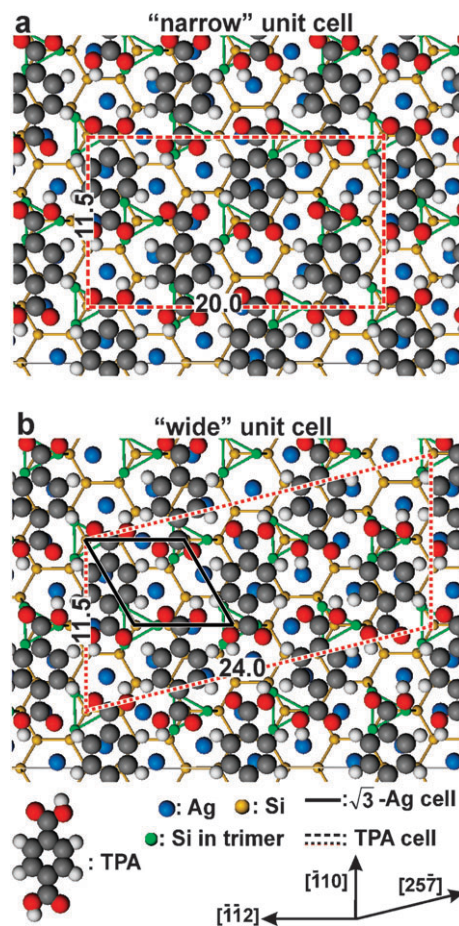


Fig. 5 Schematic drawings of possible structural models for the TPA molecular layer on Si(111)- $\sqrt{3} \times \sqrt{3}$ -Ag for (a) the n and (b) the w regions.

and

$$\begin{pmatrix} 3 & 0 \\ -2 & 7 \end{pmatrix},$$

and are indicated by dashed and dotted lines in Fig. 5(a) and (b), respectively. From the STM experiments, it is difficult to determine whether TPA molecules are deprotonated as observed on some metal substrates^{13,14}. Further spectroscopic studies are needed in order to determine this issue.

3.3 TPA on Ag(111)

Fig. 6 shows an STM image of TPA layers formed on the Ag(111) surface. The large size of the molecular islands and the absence of stray molecules indicate a high mobility of TPA on the Ag(111) surface. The molecules form a well-defined, brick wall-like ordered layer which appears to be nearly identical to that observed by Clair *et al.* on Au(111).¹³ Similarly to the Si(111)- $\sqrt{3} \times \sqrt{3}$ -Ag case, the TPA molecules arrange head-to-head in rows so that dimeric H-bonds are formed between the carboxyl end groups. The molecular spacing along these rows is 10.0 ± 0.5 Å, which corresponds to a H-bond length of ~ 2.0 Å, similar to the values reported for Au(111) and measured on Si(111)- $\sqrt{3} \times \sqrt{3}$ -Ag. Across the rows, the molecules show a very regular spacing of 6.1 ± 0.5 Å, which is most probably regulated by an attractive electrostatic or H-bond type interaction, which is similar to the inter-row distances measured on Si(111)- $\sqrt{3} \times \sqrt{3}$ -Ag: 4.7 and 5.0 Å for *n* and *w* stripes, respectively. The modulation of the TPA layer seen on the Si(111)- $\sqrt{3} \times \sqrt{3}$ -Ag surface is not observed on Ag(111). This is most probably due to a spatial modulation of the adsorption potential on the passivated semiconductor substrate which, contrarily, is much smoother on the metal substrate. In turn, this could be due to the local electronic density of states being uniform on Ag(111) but highly inhomogeneous on Si(111)- $\sqrt{3} \times \sqrt{3}$ -Ag.

Both TPA with intact^{13,15} and with deprotonated carboxylic acid groups¹⁴ have been reported to adopt a brick wall-like ordering on metal substrates. However, the deprotonation of benzene carboxylic acids on metal substrates needs to be catalyzed either by a reactive surface^{14,21} or by metal adatoms.⁴⁷ This was not observed for TPA on Au(111)¹³ nor for TMA on Ag(111) at room temperature.⁴⁷ As a

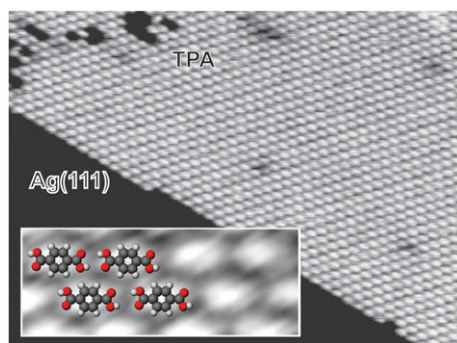


Fig. 6 STM image after the deposition of TPA on Ag(111) (36×27 nm). TPA molecules pack tightly on the surface to form large islands stabilized by intermolecular hydrogen bonding. Inset shows detail of the supramolecular structure (4.1×1.5 nm).

consequence, we speculate that TPA also adsorbs on Ag(111) in its intact acidic form.

3.4 Fe deposition onto the TPA layer on Ag(111) and Si(111)- $\sqrt{3} \times \sqrt{3}$ -Ag

Planar benzene carboxylic acids were shown to form 2D MOFs when deposited onto metal substrates together with various *d*-transition metals such as Fe, Co and Cu.^{16–23} These frameworks are characterized by a high degree of perfection since their assembly is based on reversible interactions which allow self-selection, -recognition and -correction processes to occur.²² It has been recently demonstrated that, similarly to their 3D counterparts, 2D MOFs are also stabilized by genuine charge-transfer coordination bonding and that the metallic centers are characterized by well-defined oxidation states.²³ Such systems might be interesting not only as ordered 2D patterns with possible applications in host–guest reactions, nano reactors, *etc.* but also for the catalytic and magnetic properties of low-coordinated metallic centers. In particular, TPA has shown a great versatility as a molecular elementary building block for 2D MOFs on various substrates.

On Ag(111) the sequential deposition of TPA and Fe at room temperature followed by annealing at 130 °C results in formation of large domains of a highly ordered open lattice

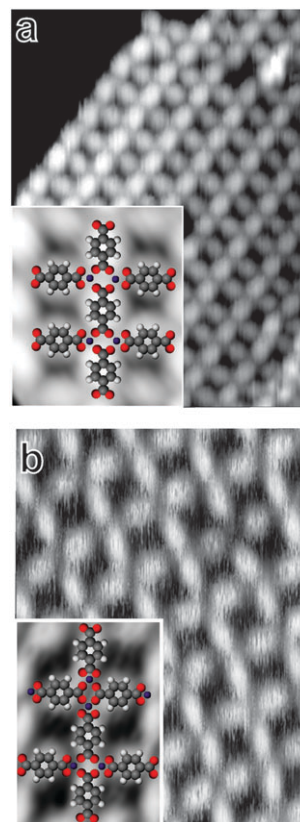


Fig. 7 STM images after the Fe deposition on the TPA molecular layer on Ag(111). Two types of 2D metal-organic networks are formed and co-exists on the surface: (a) rectangular and (b) square networks, as discussed in the text. The image sizes are (a) 12×18 nm² and (b) 7×11 nm², respectively. Insets ((a) 3.0×3.5 nm² and (b) 3.0×4.0 nm², respectively) show details of the networks.

structure, as shown in the STM images in Fig. 7. The lattice structure and size are very similar to the diiron-terephthalate 2D MOFs formed on Cu(100)^{16,17} and Au(111)¹⁹ and to the dicobalt-terephthalate formed on Au(111).²⁰ Two phases coexist on the Ag(111) surface which differ in the orientation of neighboring Fe dimers. Similarly to what is observed on Cu(100),¹⁶ the relative orientation of the dimers can either be the same for every node of the network (rectangular phase, Fig. 7(a)) or it can be alternately perpendicular (square phase, Fig. 7(b)). In the first case, half of the TPA molecules form two bidentate bonds with Fe dimers (bridging position) and the other half form two monodentate bonds (axial dimer position). In the latter case, each TPA molecule forms one bidentate and one monodentate bond with Fe centers. The rectangular nanopores (Fig. 7(a)) are $(15.8 \pm 0.5) \times (10.7 \pm 0.5)$ Å in size while the square ones (Fig. 7(b)) have a nanopore sidelength of 13.3 ± 0.5 Å. Because of their very similar overall extension (domain size), the two phases must be nearly equivalent in energy.

In order to investigate whether similar 2D MOFs can form also on a passivated semiconductor substrate, we deposited Fe on the TPA layers formed on Si(111)- $\sqrt{3} \times \sqrt{3}$ -Ag. The STM image in Fig. 8 clearly demonstrates that, in contrast to the case of metal substrates, no 2D MOFs are formed. The original H-bonded TPA layer stays intact (including its modulation) and bright protrusions can be observed, which we identify as Fe or Fe-silicide clusters. Sample annealing up to 100 °C does not produce any noticeable change, while for higher temperatures, the TPA molecules start to desorb.

One of the possible reasons explaining why the 2D MOFs do not develop on the Si(111)- $\sqrt{3} \times \sqrt{3}$ -Ag surface might be that Fe forms 3D Fe-silicide islands on this surface,⁴⁸ while it adopts an epitaxial layer-by-layer growth mode on Ag(111).⁴⁹ Therefore, the tendency toward intermixing of Fe with Si might prevent the formation of iron-terephthalate networks on Si(111)- $\sqrt{3} \times \sqrt{3}$ -Ag. A second impediment to 2D MOF assembly is the different catalytic effect of the two substrates for carboxylic acid deprotonation. Similarly to what happens in solution chemistry, the formation of metal-organic coordination bonds on surfaces requires the deprotonation

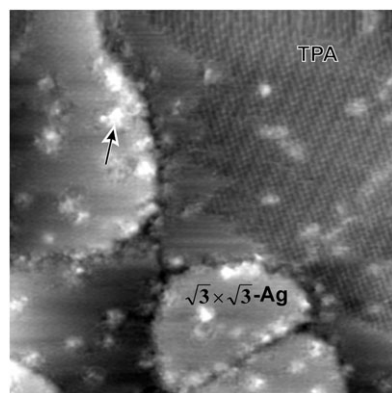


Fig. 8 STM image after the Fe deposition on the TPA molecular layer on Si(111)- $\sqrt{3} \times \sqrt{3}$ -Ag ($V_s = -1.0$ V, $I = 0.2$ nA). The image size is 50 × 50 nm. An Fe or Fe-silicide cluster is indicated by an arrow.

of the carboxylic acid groups. While this occurs readily on certain substrates such as Cu(100),^{15,23} Cu(110)²¹ or Pd(111),¹⁴ it does not take place spontaneously on Au(111)¹³ or Ag(111), as demonstrated by the results shown in section 3.3. On these latter surfaces, however, the deprotonation of the carboxylic groups is induced by the deposition of Fe,¹⁹ Co²⁰ or Cu adatoms,⁴⁷ enabling the formation of 2D MOFs (see Fig. 7). However, in the present case, Fe co-deposition with TPA on the Si(111)- $\sqrt{3} \times \sqrt{3}$ -Ag surface does not lead to deprotonation of the carboxylic acid groups. This would imply that catalysis of the deprotonation process by Fe adatoms requires a specific surface or interface electronic structure between TPA and the “true” metallic substrate, which is different from that on a passivated semiconductor substrate.

4. Summary

We have presented an STM investigation of supramolecular self-assembly on semiconductor, passivated semiconductor and metal surfaces, using the adsorption of TPA on Si(111)- 7×7 , Si(111)- $\sqrt{3} \times \sqrt{3}$ -Ag and Ag(111) as model systems. Due to a strong molecule-substrate interaction, TPA does not form any ordered molecular layer but adsorbs randomly on the Si(111)- 7×7 surface with several adsorption configurations. On the contrary, TPA forms an ordered layer stabilized by intermolecular H-bonds on Si(111)- $\sqrt{3} \times \sqrt{3}$ -Ag. A very similar brick wall-like supramolecular layer is observed for the deposition of TPA on Ag(111), indicating that both substrates allow similar supramolecular self-assembly of organic molecules. On the other hand, the deposition of Fe on the TPA layers induces the formation of 2D MOFs only for the Ag(111) substrate. Possible reasons for this difference might be the tendency of Fe to intermix with Si and/or the catalytic role of metal substrates in the deprotonation of carboxylic groups. Although further studies are needed to clarify these issues, our investigation clearly demonstrates that metal-passivated semiconductor surfaces behave similarly to “true” metallic ones for molecular adsorption and self-assembly. However, their different electronic properties might show up in a different reactivity towards single metallic centers and the deprotonation of carboxylic groups, preventing the formation of 2D MOFs.

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